



AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1752
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68577

Akihiro HASHIGUCHI

Appln. No.: 10/076,447

Group Art Unit: 1752

Confirmation No.: 9868

Examiner: Thorl CHEA

Filed: February 19, 2002

For: THERMAL DEVELOPMENT SYSTEM AND APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 1, 2003, please amend the above-identified application as follows:

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GROUP 1700